UNIVERSITY OF SOUTH FLORIDA

Major Research Area Paper Presentation

Active Learning and Preprocessing for Medical Histopathology -A Literature Review

by

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For the Ph.D. degree in Computer Science and Engineering

The most pressing issue in the application of deep learning to medical histopathology is the clash between the voracious appetites for data of supervised deep learning algorithms and the difficulty and cost of acquiring that data. Research for effective machine learning in the medical field is just as well research to either improve performance using less data, or cheaply and automatically label new data. A promising approach to this problem is active learning in its numerous variations. We will review recent advances in the application of active learning to medical histopathology, and we will review the challenges of applying the method to deep learning. We will discuss uncertainty sampling variants of active learning as well as new variants which enable automatic labeling. Then, we will review the challenges of inconsistent microscopy conditions which hurt the performance of machine learning models, and review approaches to preprocessing which attempt to normalize these inconsistencies for analysis by both human researchers and machine learning algorithms.

Thursday, April 29, 2021 3:00PM Online (Blackboard Collaborate) Please email for more information cjcollazo@usf.edu

The Public is Invited

Examining Committee Dmitry Goldgof, Ph.D., Co-Major Professor Lawrence Hall, Ph.D., Co-Major Professor Sudeep Sarkar, Ph.D. Rays Jiang, Ph.D. *Mahshid Naeini*, Ph.D.

Xinming Ou, Ph.D. Associate Chair for Graduate Affairs Computer Science and Engineering College of Engineering Sudeep Sarkar, Ph.D. Department Chair Computer Science and Engineering College of Engineering

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